

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In the **PATENT APPLICATION** of:

Fu et al.

**Application No.:** 13/100,585

**Confirmation No.:** 3289

**Filed:** May 4, 2011

**For:** MATCHING METHOD OF PATTERN  
LAYOUTS FROM INVERSE LITHOGRAPHY

**Group:** 1721

**Examiner:** John S. Ruggles

**Our File:** NANYA-PT005.1

**Date:** December 23, 2011

**REPLY PURSUANT TO 37 C.F.R. §1.111**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This Reply is being timely filed in response to the Office Action dated September 27, 2011 Paper No. 20110914.

Please amend the application without prejudice or disclaimer as follows: